

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) CONFIRMATION NO.: 8915
Naoki CHIBA)
Serial No.: 09/988,630) Group Art Unit: 2621
Filed: November 20, 2001) Examiner: D. Rosario-Vasquez

For: APPARATUS FOR AND METHOD OF CALCULATING LENS DISTORTION

FACTOR, AND COMPUTER READABLE STORAGE MEDIUM HAVING LENS DISTORTION FACTOR CALCULATION PROGRAM RECORDED

THEREON

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

A response to the Office Action dated September 9, 2004 was due by December 9, 2004. A Petition for Extension of Time (two months, large entity) also is enclosed, extending the response due date to February 9, 2005. Therefore, please accept this Amendment as timely filed and fully responsive.

In response to the Office Action dated September 9, 2004, kindly amend the above-identified patent application as follows.